Electronic Acknowledgement Receipt				
EFS ID:	1060347			
Application Number:	10711298			
Confirmation Number:	5297			
Title of Invention:	DUAL SILICIDE VIA CONTACT STRUCTURE AND PROCESS			
First Named Inventor:	Michael M. Iwatake			
Customer Number:	32074			
Filer:	Yuanmin Cai/Amy Barger			
Filer Authorized By:	Yuanmin Cai			
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File Listing:

Document Number	Document Description	File Name	File Size(Bytes)	Multi Part	Pages
1	Amendment After Final	fis920040156AmendAfterFin al.pdf	304505	no	8

Warnings:	
Information:	
Total Files Size (in bytes):	304505

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New Applications Under 35 U.S.C. 111

If a new application is being filed and the application includes the necessary components for a filing date (see 37 CFR 1.53(b)-(d) and MPEP 506), a Filing Receipt (37 CFR 1.54) will be issued in due course and the date shown on this Acknowledgement Receipt will establish the filing date of the application.

National Stage of an International Application under 35 U.S.C. 371

If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in due course.